

Course Schedule - Fall 2005

Electrical and Computer Engineering

485 *Intro MEM Devices & Systems* Credit: 3 hours.

(ECE 385) Course presents an introduction to the principles, fabrication techniques, and applications of microelectromechanical systems (MEMS). Students will gain an in-depth understanding of sensors and actuator principles and integrated microfabrication techniques for MEMS. It also consists of a comprehensive investigation of the state-of-the-art MEMS devices and systems. Same as IE 485 and ME 485. Prerequisite: Senior standing in the College of Engineering.

CRN	Type	Section	Time	Days	Location	Instructor
36987	lecture	C	10:00 AM - 11:20 AM	MW	room 148 Henry Administration Bldg	Liu, C
36987: 3 hours						